## Printed Pages—3

**EEC301** 

(Following Paper ID a	and Roll No.	to be f	filled i	n you	r Ans	wer	Book)
<b>PAPER ID : 0322</b>	Roll No.			11	Τ		

## B.Tech.

## (SEM. III) ODD SEMESTER THEORY EXAMINATION 2012-13 FUNDAMENTALS OF ELECTRONIC DEVICES

Time : 3 Hours

Total Marks: 100

Note: Attempt all questions. All questions carry equal marks. Assume suitable data if not given.

- 1. Attempt any **four** parts of the following : (5×4=20)
  - (a) With suitable sketch describe briefly the diamond lattice.
  - (b) What is Miller Indices ? What is the advantage of taking the reciprocals of the intercepts in determination of Miller Indices of a particular plane ? Explain with example.
  - (c) Calculate the density of GaAs if the lattice constant of GaAs is  $5.65 \times 10^{-8}$  cm. The atomic weights of Ga and As are 69.7 and 74.9 grams/mole respectively. Also, given Avogadro's Number =  $6.02 \times 10^{23}$  atoms/mole.
  - (d) What do you mean by effective mass of carriers? What is the kinetic energy of a hole at the top of the valence bond?
  - (e) Define Fermi level and sketch the Fermi function at 0°C. Calculate the probabilities of finding electrons and holes at the energy level of 0.1 eV above and below the Fermi level at temperature 0 K.
  - (f) Calculate minimum conductivity of Si at 300 K. Derive the expression used, if any.

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**[Turn Over** 

2. Attempt any **four** parts of the following :

- (a) In Si semiconductor it is observed that three quarters of current is carried by holes and the rest part by electrons. What is the ratio of electrons to holes concentration ?
- (b) Distinguish between traps and recombination center. Explain with suitable sketch.
- (c) What do you mean by photoluminescence ? Explain with suitable sketch, the difference between fluorescents and phosphors.
- (d) Define and derive the expression for minority carrier life time.
- (e) Define quasi Fermi levels. Also show that for steady state condition the product of electron and hole concentrations is equal to  $n_i^2 e^{(F_n F_p)/KT}$ , where  $n_i$  is intrinsic carrier concentration and  $(F_n F_p)$  is the separation of the quasi-Fermi levels.
- (f) What is the physical significance of diffusion length ? How is it related with mobility of the carrier ?
- 3. Attempt any two parts of the following : (10×2=20)
  - (a) What is contact potential ? Explain. Derive an expression for it assuming step junction at equilibrium condition.

For Si p-n junction, donor and acceptor impurities at room temperature are  $10^{16}$  cm<sup>-3</sup> and  $3 \times 10^{18}$  cm<sup>-3</sup> respectively. Calculate the contact potential and draw an equilibrium band diagram for the junction if intrinsic carrier concentration of Si is  $1.5 \times 10^{10}$  cm<sup>-3</sup> at room temperature.

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- (b) Derive an expression for the current-voltage relation in an ideal p-n junction diode.
- (c) Assume that an ideal Schottky barrier is formed on ntype Si having 10<sup>15</sup> As atoms per cm<sup>3</sup>. The metal work function is 4.3 eV and Si electron affinity is 4 eV. Draw the equilibrium band diagram with values calculated for appropriate barriers and describe the contact.
- 4. Attempt any two parts of the following : (10×2=20)
  - (a) What are the basic difference between the FET and BJT? Describe the construction, operation and characteristics of an enhancement type MOSFET.
  - (b) What are the special features of MESFET ? Explain the working of normally-off MESFETs with its characteristics.
  - (c) Explain how a Bipolar Junction Transistor can be used as an amplifier. Define the emitter injection efficiency, current transfer ratio and Base-to-Collector current amplification factor.
- 5. Attempt any two parts of the following :  $(10 \times 2 = 20)$ 
  - (a) What is meant by IMPATT ? Explain the construction and operation of an IMPATT diode.
  - (b) Discuss the switching mechanism of the p-n-p-n diode with the help of the two transistor analogy.
  - (c) What is photodiode ? What are its different types ? Describe the construction of a photodiode with its operation.

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